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PATENT APPLICATION

THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Attn: OIPE

Seigo KODAMA et al.

Group Art Unit: 3729

Application No.: 10/564,815

Docket No.: 126601

Filed: February 14, 2006

For: MANAGING APPARATUS FOR MANAGING ASSISTING WORK TO ASSIST SUBSTRATE-RELATED-WORK PERFORMING SYSTEM, AND MANAGING PROGRAM FOR MANAGING ASSISTING WORK TO ASSIST SUBSTRATE-RELATED-WORK PERFORMING SYSTEM

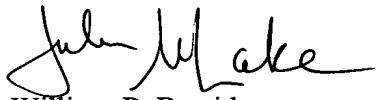
REQUEST FOR CORRECTION OF PALM RECORDS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Attached is a photocopy of the original filing receipt on which errors have been corrected in red. These errors are being brought to the attention of the Patent and Trademark Office so that it may correct its records.

Respectfully submitted,


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WPB:JML/hjr

Date: July 18, 2006

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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY.DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/564,815	02/14/2006	3729	1030	126601	17	16	2

CONFIRMATION NO. 3390

25944
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P.O. BOX 19928
ALEXANDRIA, VA 22320

JUN 07 2006

FILING RECEIPT



OC000000019057042

Date Mailed: 06/02/2006

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please mail to the Commissioner for Patents P.O. Box 1450 Alexandria Va 22313-1450. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

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Assignment for Published Patent Application

Fuji Machine MFG. Co., Ltd., Chiryu-shi, JAPAN

Power of Attorney: The patent practitioners associated with Customer Number 25944.

Domestic Priority data as claimed by applicant

This application is a 371 of PCT/JP04/09956 07/13/2004

Foreign Applications

JAPAN 2003-199391 07/18/2003

If Required, Foreign Filing License Granted: 06/01/2006

The country code and number of your priority application, to be used for filing abroad under the Paris Convention, is **US10/564,815**

Projected Publication Date: 09/07/2006

Non-Publication Request: No

Early Publication Request: No

Title

Correction Also
On Page 2



~~Assisting work management apparatus for substrate work system and assisting work management program for substrate work system~~

Preliminary Class

~~029 Managing apparatus for managing assisting work to assist substrate-related-work performing system, and managing program for managing assisting work to assist PROTECTING YOUR INVENTION OUTSIDE THE UNITED STATES~~

Substrate - related - work performing System

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